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Date June 30, 2003Number of pages including cover sheet 8**To:**Examiner T. H. MeeksArt Unit 1762USPTOUSSN 09/896,955

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From:Gary CohnGary C. Cohn PLLC4010 Lk. Wash. Blvd.Suite 105Kirkland, WA 98033Phone (425) 576-1656Fax Phone (425) 576-1756**REMARKS:**☐ Urgent☒ For your review☐ Reply ASAP☐ Please comment

Response to March 28, 2003 office action (7 pp.) attached.

Gary C. Cohn

USSN 09/896,955

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant (s): Steven M. George et al.

Serial No.: 09/896,955

Group Art Unit: 1762

Filed: June 29, 2001

Examiner: Meeks

For: METHOD FOR FORMING SiO₂ BY CHEMICAL VAPOR DEPOSITION AT ROOM TEMPERATURE

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING SENT BY FACSIMILE ON JUNE 30, 2003	
DATE OF DEPOSIT	
Gary C. Cohn	
PRINT OR TYPE NAME OF PERSON SIGNING CERTIFICATE	
SIGNATURE OF PERSON SIGNING CERTIFICATE	

#6/a
Jugda
7/1/03

**Hon. Commissioner of Patents & Trademarks
Washington, D.C. 20231**

Sir:

RESPONSE A

This paper is submitted in response to the office action in this case mailed March 28, 2003. The examiner is respectfully requested to enter the following amendments and to reconsider the application in view of the following remarks.

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